

#4 0300

500.41296X00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): R. UDO ET AL.

4 / IDS  
E. Willis  
7-9-02

Serial No.: 10/083,255

Filed: February 27, 2002

For: SEMICONDUCTOR PROCESSING APPARATUS AND  
WAFER SENSOR MODULE

**INFORMATION DISCLOSURE STATEMENT**  
**UNDER 37 CFR §1.97 & §1.98**

Assistant Commissioner of Patents  
Washington, D.C. 20231

April 10, 2002

Sir:

In the matter of the above-identified application, Applicants are submitting herewith a copy of the document listed in the attached form equivalent to Form PTO-1449 for the Examiner's consideration which was disclosed in the above-identified application.

This information disclosure statement is being submitted within three months of the filing date of the above-identified application.

To the extent that, the documents listed on the attached form equivalent to Form PTO-1449, are not in the English language, the requirement of 37 CFR §1.98(a)(3) for a concise explanation of the relevance is satisfied by an English

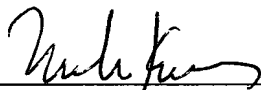
language version or translation of the foreign patent office report citing the documents.

It is respectfully requested that this Information Disclosure Statement be considered by the Examiner.

Please charge any shortage in the fees due in connection with the filing of this paper, including extension of time fees, to Deposit Account No. 01-2135 (500.41296X00) and please credit any excess fees to such deposit account.

Respectfully submitted,

ANTONELLI, TERRY, STOUT & KRAUS, LLP



---

Melvin Kraus  
Registration No. 22,466

MK:alw  
(703) 312-6600